



Patent
Attorney's New Docket No. 1003510-000161
Attorney's Old Docket No. 018765-177

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| | |
|----------------------------------|------------------------------|
| In re Patent Application of |) MAIL STOP AMENDMENT |
| Tsutomu SAIMOTO et al. |) |
| Application No.: 10/506,806 |) Group Art Unit: 2811 |
| Filed: September 7, 2004 |) Examiner: Thomas J. Magee |
| For: PRESSURE SENSITIVE ADHESIVE |) Confirmation No.: 5415 |
| FILM FOR PROTECTION OF |) |
| SEMICONDUCTOR WAFER |) |
| SURFACE AND METHOD OF |) |
| PROTECTING SEMICONDUCTOR |) |
| WAFER WITH THE PRESSURE |) |
| SENSITIVE ADHESIVE FILM |) |

**AMENDMENT AND RESPONSE TO RESTRICTION/UNITY
OF INVENTION REQUIREMENT**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed January 3, 2006, please amend the
above-identified application as follows: